"RESPONSE UNDER 37 CFR 1. EXPEDITED PROCEDURE EXAMINING **GROUP 3742"**

Docket No.

221014US90 PCT

IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.

FILED:

SERIAL NO: 10/070,443 June 24, 2002

FOR:

CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE, PROCESS OF PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE CERAMIC HEATER

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an AMENDMENT AFTER FINAL UNDER 37 C.F.R. 1.116 in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

*ČLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE	:	CALCULATIONS
TOTAL	12	MINUS	20	0	х	\$50	1	\$0.00
INDEPENDENT	1	MINUS	3	0	x	\$200	=	\$0.00
		☐ MULTIPL	E DEPENDENT	CLAIMS	+	\$360		\$0.00
	TOTAL OF ABOVE CALCULATIONS						NS	\$0.00
	☐ Reduction by 50% for filing by Small Entity						\$0.00	
		☐ Recordation of Assignment			+	\$40	=	\$0.00
						TOT	AL	\$0.00

- \square A check in the amount of **\$0.00** is attached.
- ☐ Credit card payment form is attached to cover the fees in the amount of **\$0.00**
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

Masayasu Mori

Registration No. 47,301

Customer Number

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

Christopher D. Ward Registration No. 41,367



DOCKET NO: 221014US90 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

:

Yasuji HIRAMATSU, et al.

: EXAMINER: FUQUA, S.

SERIAL NO.: 10/070,443

:

FILED: June 24, 2002

: GROUP ART UNIT: 3742

FOR: CERAMIC HEATER FOR A

SEMICONDUCTOR

PRODUCING/EXAMINING DEVICE, PROCESS OF

PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE CERAMIC

HEATER

AMENDMENT AFTER FINAL UNDER 37 CFR 1.116

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 25, 2005, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.